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November 21, 2000

11/21/00  
Date

Marilyn B. McKenna  
Signature



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Reid A. BRENNEN et al.

Group Art Unit: 1756

Serial No.: 09/233,694

Examiner: C. Young

Filing Date: January 19, 1999

Title: METHOD FOR PRODUCING HIGH-SURFACE  
AREA TEXTURING OF A SUBSTRATE,  
SUBSTRATES PREPARED THEREBY AND  
MASKS FOR USE THEREIN

**RESPONSE TO FINAL REJECTION**  
**EXPEDITED PROCEDURE - EXAMINING GROUP 1756**

Assistant Commissioner for Patents  
Washington, D.C. 20231

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Sir:

This is in response to an Office Action on the merits concerning the patent application identified above, mailed from the PTO on September 22, 2000. Reconsideration of the application in view of remarks is respectfully requested.

**REMARKS**

**INTRODUCTORY COMMENTS:**

Claims 23-27, 29-46, 48-50, 52-69, 77 and 78 are currently pending. In a previous Office Action, all pending claims were rejected under 35 U.S.C. §102(b) as anticipated by or, in the alternative, under 35 U.S.C. § 103(a) as obvious over either one of U.S. Patent Nos. 5,571,410 to